



EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Keiichi TAKANASHI et al

Serial No. 10/822,662

Filed: April 13, 2004

For: DEVICE AND METHOD FOR  
MEASURING POSITION OF  
LIQUID SURFACE OF MELT IN  
SINGLE-CRYSTAL-GROWING  
APPARATUS

Confirmation No.: 3146

Examiner: Robert M. Kunemund

Group Art Unit: 1722

RESPONSE TO OFFICE ACTION OF MARCH 20, 2006

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22314-1450

Sir:

Responsive to the Office Action of March 20, 2006, please amend the captioned application as follows: